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LIST OF ART CITED BY APPLICANT  
(PTO-1449)

ATTY. DOCKET NO.  
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APPLN. SERIAL NO.  
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**APPLICANT(S)**

**Do-Hoon KIM**

**FILING DATE**  
**October 24, 2003**

**GROUP**

## U.S. PATENT DOCUMENTS

[illegible]

## U.S. PATENT APPLICATION PUBLICATIONS

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	

## U.S. PATENT APPLICATIONS

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	

## FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
B M	WO98/00996	1/8/1998	WIPO			XX	
	EP0413311	2/20/1991	EUROPE			XX	

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)**

**Chinese Office Action Dated September 30, 2005**

**EXAMINER**

DATE CONSIDERED

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